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CERTIFICATE OF MAILING
37 C.F.R. 1.8

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Rebecca Ginn

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Cem Basceri, et al.

Group Art Unit: 1763

Serial No.: 10/762,706

Examiner: Jeffrie R. Lund

Filed: 1/22/2004

Atty. Dkt. No.: 102-0075US2

For: Micromachines for Delivering
Precursors and Gases
for Film Deposition

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria VA, 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement (IDS) be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents are attached.

In accordance with 37 C.F.R. §§ 1.97(g),(h), this IDS is not to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b), or that such information constitutes prior art.

This IDS is being filed after receipt of a first office action on the merits. Accordingly, a fee is believed due pursuant to 37 C.F.R. § 1.17(p)/1.97(c). The PTO is authorized to deduct

such fee, and any other necessary fees, from Deposit Account No. 501922, referencing matter no. 102-0075US2.

Applicant respectfully requests that the listed documents be considered and made of record in the present case, and that the Examiner initial the appropriate spaces on the Form 1449 to evidence the same

Respectfully submitted,



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8/21/2005

Form PTO-1449 (modified)

Atty. Docket No.

102-0075US2

Serial No.

10/762,706

List of Patents and Publications for Applicant's

Applicant / Inventor

Micron Technology, Inc., / Cem Basceri et al.

INFORMATION DISCLOSURE STATEMENT

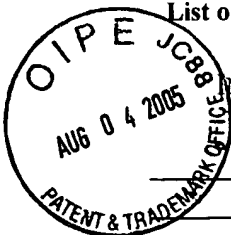
Filing Date:

1/22/2004

Group:

1763

(Use several sheets if necessary)

**U.S. Patent Documents**

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1	5,272,797	12/28/1993	Miyoshi	29	25.35	
	A2	6,561,207	5/13/2003	Lowery et al.	137	1	2/21/2002
	A3						
	A4						
	A5						
	A6						
	A7						

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	

EXAMINER:**DATE CONSIDERED:**

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

INFORMATION DISCLOSURE STATEMENT — PTO-1449 (MODIFIED)

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